

國立交通大學

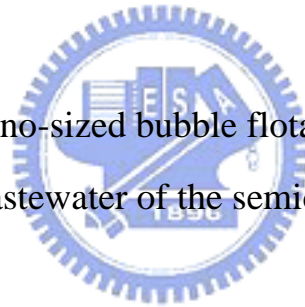
環境工程研究所

碩士論文

奈米微氣泡浮除技術於半導體工業

化學機械研磨廢水處理之應用

The application of nano-sized bubble flotation technology on the
treatment of CMP wastewater of the semiconductor manufactory



研究生：蘇揚根

指導教授：林志高 博士

中華民國九十三年七月

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